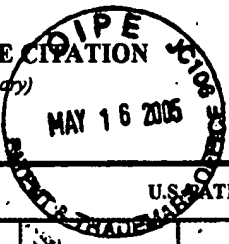


INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				Docket Number (Optional) 16790		Application Number 10/606,518		
				Applicant(s) Takami Shibazaki, et al.				
				Filing Date June 26, 2003		Group Art Unit 2877		
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
SDP		5,880,473	3/9/99	Ginestet				
U.S. PATENT APPLICATION PUBLICATIONS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
SDP		WO 98/07022	2/19/98	PCT			✓	
SDP		WO 00/05571	2/3/00	PCT			✓	
SDP		01-292238	11/24/89	Japan				✓
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
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